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Form PTO-1449 Modified List of Patents and Publications Cited by Applicant (Use several sheets if necessary) U.S. Department of Commerce	Docket No. DRE0158US.NP	Serial No. 10/576,990
	Applicant R. Andrew Hicks	
	Filing Date Not Yet Assigned	Group Not Yet Assigned

U. S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Name	Class	Subclass
/JV/	AA	5,369,433	11-29-94	Baldwin et al.	348	207
/JV/	AB	5,212,555	5-18-93	Stoltz	358	206
/JV/	AC	5,612,736	3-18-97	Vogeley et al.	348	207
/JV/	AD	6,690,885	2-10-04	Aksyuk et al.	398	45
/JV/	AE	6,700,606	3-2-04	Borza	348	218.1

FOREIGN PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Country	Translation YES NO

EXAMINER /John Villecco/

DATE CONSIDERED 08/29/2008

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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)			
/JV/	BA	Hornbeck, Larry J., "From cathode rays to digital micromirrors: A history of electronic projection display technology", Texas Instruments Technical Journal 1998 15:7-46	
/JV/	BB	Kropp et al., "Acquiring and Rendering High-Resolution Spherical Mosaics", Proceeding IEEE Workshop on OmniDirectional Vision 2000 47-53	
/JV/	BC	Nakao et al., "Panoramic Camera Using a Mirror Rotation Mechanism and a Fast Image Mosaicing", International Conference on Image Processing, 2001 2:1045-1048	
/JV/	BD	Nayar et al., "Programmable Imaging using a Digital Micromirror Array", XCVPR 2004 1:436-443	
/JV/	BE	Wu, Ming C., "Micromachining for Optical and Optoelectronic Systems", Proceedings of the IEEE 1997 85(11):1833-1856	
EXAMINER /John Vilecco/		DATE CONSIDERED 08/29/2008	